



Docket No.: 0171-1022P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Takeshi KINSHO et al.

Application No.: 10/671,732

Confirmation No.: 6775

Filed: September 29, 2003

Art Unit: 1752

For: POLYMERIZABLE SILICON-CONTAINING
COMPOUND, MANUFACTURING METHOD,
POLYMER, RESIST COMPOSITION AND
PATTERNING PROCESS

Examiner: S. J. Lee

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated July 18, 2006, finally rejecting claim 1, please
amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 11 of this paper.

Please
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S.J.L.
10/30/06
S. J. Lee